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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10045278	FILING DATE 01/14/2002	CLASS 438	SUBCLASS 2812	GAU 2812	EXAMINER
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**APPLICANTS: Gehring Oliver; Langheinrich Wolfram;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:
GERMANY 101 01 270.5 01/12/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed: ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

PEK-In1112

TITLE : Method for fabricating embedded nonvolatile semiconductor memory cells

U.S. DEPT. OF COMM/PAT & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED

ISSUE FEE	
Amount Due	Date Paid

☐ TERMINAL
DISCLAIMER

Assistant Examiner

Primary Examiner

PREPARED FOR ISSUE

CLAIMS ALLOWED

Total Claims	Print Claim for O.G.
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DRAWING

Sheets Drawg.	Figs. Drawg.	Print Fig.
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Application Examiner

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☐ CD-ROM

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